

SCIENTIFIC REPORTS



OPEN

Optically tuned terahertz modulator based on annealed multilayer MoS₂

Received: 02 November 2015

Accepted: 24 February 2016

Published: 08 March 2016

Yapeng Cao^{1,2}, Sheng Gan³, Zhaoxin Geng^{1,4}, Jian Liu², Yuping Yang⁵, Qiaoling Bao³ & Hongda Chen¹

Controlling the propagation properties of terahertz waves is very important in terahertz technologies applied in high-speed communication. Therefore a new-type optically tuned terahertz modulator based on multilayer-MoS₂ and silicon is experimentally demonstrated. The terahertz transmission could be significantly modulated by changing the power of the pumping laser. With an annealing treatment as a p-doping method, MoS₂ on silicon demonstrates a triple enhancement of terahertz modulation depth compared with the bare silicon. This MoS₂-based device even exhibited much higher modulation efficiency than the graphene-based device. We also analyzed the mechanism of the modulation enhancement originated from annealed MoS₂, and found that it is different from that of graphene-based device. The unique optical modulating properties of the device exhibit tremendous promise for applications in terahertz switch.

In the last decade, terahertz (THz) waves, whose wavelength is 100–1000 μm, have aroused researchers' interest because of its unique properties. Recently, THz technology has been applied in imaging¹, bio-sensing² and communication^{3,4}. Meanwhile, a great of progresses has been made in THz devices such as THz sources^{5,6}, detectors^{7,8}, and modulators. Among these devices, THz modulators are very important in THz communication. In previous studies, different types of THz wave modulators have been reported, including devices based on GaAs⁹, silicon¹⁰, metamaterials^{11–16}, silicon on sapphire (SOS)¹⁷, germanium¹⁸ and graphene^{18–24}. As THz waves can be absorbed by a conductor, the basic way to modulate THz waves is to tune the conductivity of a semiconductor with an external voltage signal or a pumping light. Though both electrically and optically tuned modulators are practicable, the modulation speed of an optically tuned device is usually faster than that of an electrically tuned one²⁵, as the latter is limited by the device charging time of depletion capacitance at the Schottky diode formed by the contact of metal and semiconductor²⁶. For optically tuned devices, the modulation speed is mainly correlated with the lifetime of the photogenerated free carriers. Most of the optically tuned devices reported in literatures use femtosecond lasers as optical pumping sources to provide high power pulses so that massive free carriers can be excited during the THz probing. Switching time less than several nanoseconds and modulation depth of more than 70% have been demonstrated in those experiments²⁷. However, it is more practicable in applications to use a continuous wave (CW) laser instead of femtosecond laser to modulate the pumping light with a particular signal. The disadvantage for CW lasers lies that its transient beam power is much lower than that of a femtosecond laser. Hence the concentration of free carriers in the device is much smaller and the change of conductivity may be not enough to realize a large THz modulation depth. One solution to improve the THz modulation efficiency is to use lightly doped silicon or materials with long carrier lifetime, such as germanium¹⁸. Meanwhile, a longer lifetime of free carriers means a slower modulation speed. One has to make a balance between the modulation depth and speed. Another solution is to introduce new materials into the device, to enhance the modulation effect of THz waves. Recently Rahm *et al.*²² has demonstrated a THz modulator based on optically tuned graphene-silicon system. A significant enhancement in THz transmission was induced by graphene due to its high mobility.

¹State Key Laboratory of Integrated Optoelectronics, Institute of Semiconductors, Chinese Academy of Sciences, Beijing, 100083, China. ²State Key Laboratory of Superlattices and Microstructures, Institute of Semiconductors, Chinese Academy of Sciences, Beijing, 100083, China. ³Institute of Functional Nano and Soft Materials (FUNSOM), Soochow University, Suzhou 215123, China. ⁴School of Information Engineering, Minzu University of China, Beijing 100081, China. ⁵College of Science, Minzu University of China, Beijing 100081, China. Correspondence and requests for materials should be addressed to Z.G. (email: gengsir@163.com) or J.L. (email: liujian@semi.ac.cn) or H.C. (email: hdchen@semi.ac.cn)

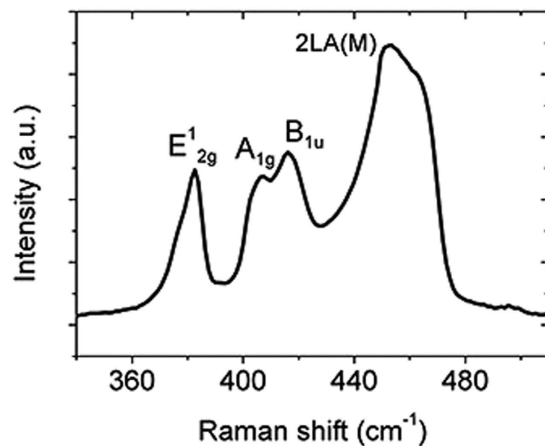


Figure 1. The Raman spectrum of multilayer MoS₂ sample on a SiO₂/Si substrate.

Graphene is just one of the numerous magical two-dimensional (2D) materials. Among these 2D materials, molybdenum disulfide (MoS₂) shows unique properties^{28,29}. The band gap of MoS₂ depends on the number of its molecule layers. Single-layer MoS₂ has a direct band gap of ~1.8 eV, while multi-layer MoS₂ has an indirect band gap of 1.2 eV³⁰. MoS₂-based devices such as photodetectors and transistors have already been reported^{31–33}. The optical and electric properties of MoS₂-based devices can be tuned by defect engineering and doping³⁴. It has been demonstrated that p-doped MoS₂ showed great enhancement in photoluminescence intensity^{35,36}. The doping process can be realized by a simple process of annealing in air or by mild O₂ plasma irradiation^{37–39}. Recently, another property of MoS₂ is demonstrated in THz range⁴⁰. MoS₂ was observed to have ultrafast photoconductivity responses of less than 1 ps. This result indicates that MoS₂ is suitable for application in high-speed THz devices. However, to our knowledge, THz modulators based on MoS₂ have not been seen until now. In this paper, we demonstrate an optically tuned terahertz modulator based on multilayer MoS₂ with an annealing treatment. It is demonstrated that annealed MoS₂ can significantly enhance the THz modulation depth of silicon under a CW pumping laser. The modulation efficiency of our device is even higher than that of graphene-based THz modulators. Therefore our work provides a new method to realize an effective THz wave modulator.

Results

The sample of multilayer MoS₂ was grown on a SiO₂/Si substrate by chemical vapor deposition (CVD). It was then transferred to a clean high-resistivity silicon substrate (1 mm thick, resistivity $\rho > 5000 \Omega \text{ cm}$, N-type). The area of CVD MoS₂ on silicon substrate is about 1 cm². The multilayer MoS₂ is verified by Raman spectroscopy. The Raman spectrum excited by 632 nm line is shown in Fig. 1a. Multiple peaks are observed including the E¹_{2g} (383 cm⁻¹), A_{1g} (406.6 cm⁻¹), B_{1u} (416 cm⁻¹) and 2LA(M) (453 cm⁻¹) peaks, agreeing with results reported in ref. 28. The position difference of E¹_{2g} and A_{1g} peaks is $\Delta = 23.6 \text{ cm}^{-1}$, indicating that the MoS₂ is multilayer.

The terahertz transmission spectra of the samples were measured using terahertz time-domain spectroscopy (THz TDS) system. A CW laser (808 nm) was used as an optical pumping source to excite photogenerated carriers in the samples. The diameter of the spot size of THz beam is about 8 mm and the beam diameter of the CW laser is about 1.5 cm. The broadband THz transmission spectra of MoS₂ on silicon sample (MOS) were measured under different optical pump power. Transmission spectra of an identical bare high-resistivity silicon sample under the same conditions were measured as a reference. A sample with single-layer graphene on silicon (GOS) was also measured as a comparison.

The measured THz transmission spectra of the MOS sample are shown in Fig. 2b. The transmittances are on the reference of the transmission spectrum of a bare silicon sample without laser illumination. It is observed that the broadband THz transmission values decrease with the pump power. This decrease is the result of the increase in conductivity of the sample caused by photogenerated carriers. So a lower transmission indicates a larger modulation of THz waves. In Fig. 2b, the transmission line of a silicon substrate is plotted (the black line) as a comparison. Under an optical pump power of 0.78 W, the MOS sample shows a bit larger transmittance compared with that of the silicon substrate. This means that MoS₂ shows no enhancement in optical modulation of terahertz wave. Meanwhile, transmission spectra of the GOS sample under different pump powers are demonstrated in Fig. 2c. Compared with that of a silicon substrate, the transmission of GOS is much smaller when the pump power is 0.78 W. These results agree with those reported in ref. 22, demonstrating that graphene can enhance THz modulating effect to a large extent. In Fig. 2d, transmittances of different samples at 0.9 THz are plotted as a function of the optical pump power. It is illustrated that modulation depths of the MOS sample and the silicon substrate are much smaller than that of the GOS sample.

It has been reported that oxygen-induced hole doping effectively enhanced the photo-luminescence of MoS₂ and changed its electronic properties^{36,38}. By annealing in air at proper temperature, the MoS₂ sample can be effectively doped with oxygen and provide numerous holes. In our following experiment, the MOS sample was placed in air and annealed at 300 °C. The MOS sample after annealing treatment was characterized with Raman spectroscopy using 632 nm laser line. As shown in Fig. 3, the E¹_{2g} peak lies at 383.3 cm⁻¹ and the A_{1g} peak lies at 407.9 cm⁻¹ (the red line). The Raman spectra of the MOS sample before annealing is plotted in black as a

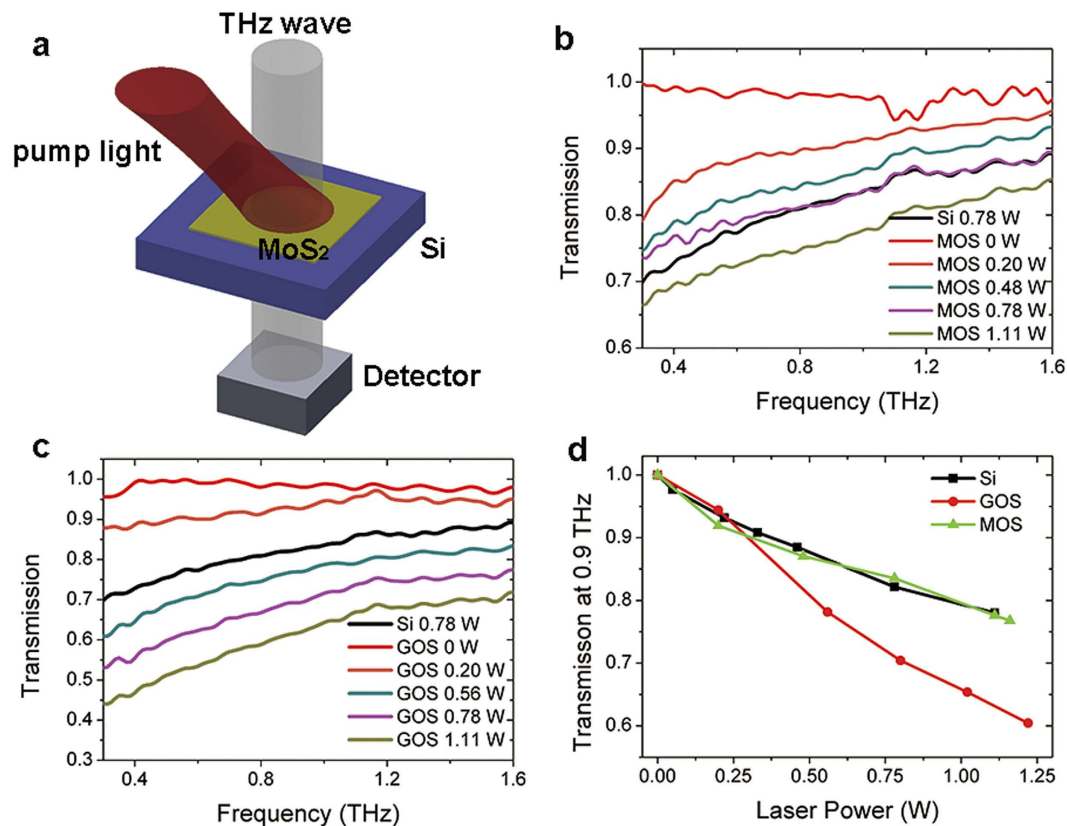


Figure 2. The measured THz transmissions of different samples under various optical pump powers. (a) A sketch map of the experiment. THz transmissions of (b) the unprocessed MOS sample and (c) the GOS sample. (d) Relationship between transmissions at 0.9 THz and the pumping laser power for different samples.

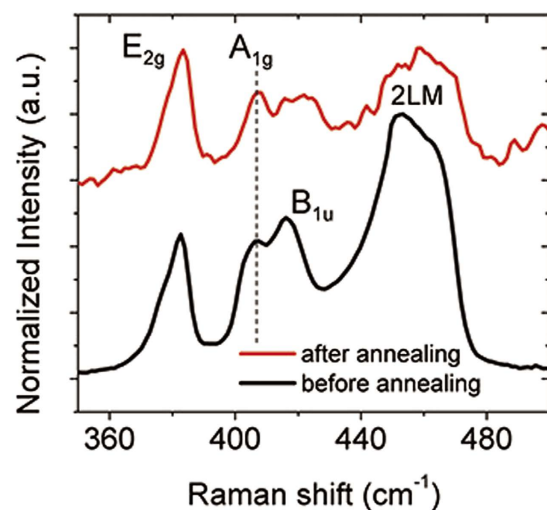


Figure 3. A comparison of Raman spectra of the MOS sample before and after the annealing treatment. The Raman intensity are normalized to their maxima.

comparison. A slight blueshift of 1.3 cm^{-1} of the A_{1g} peak is observed compared to the sample before annealing, indicating that the sample has been p-doped.

To figure out the effect of annealing treatment for MoS_2 , THz transmission spectra of the annealed MOS sample, together with the GOS sample as a comparison, are measured. In the measurement, the same 808 nm CW laser was used to modulate photo-generated carrier densities of these samples. The results are shown in Fig. 4. The MOS sample, which was heated in air for 0.5 h, demonstrates good optical modulating effect at a broad frequency band, presenting a transmission decline of $\Delta T_M = T_0 - T_p = 87\%$ in transmission at 0.9 THz under a large pump

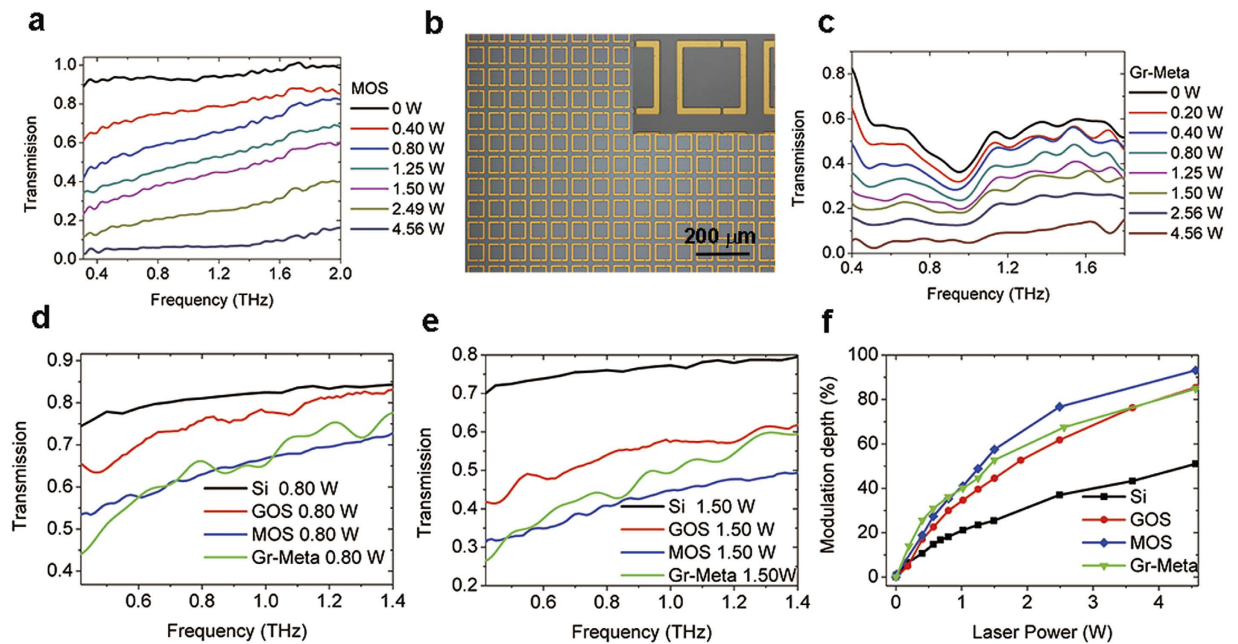


Figure 4. Broadband THz modulation in transmission of various samples under different optical pump powers. THz transmissions of (a) the annealed MOS sample and (c) the graphene on metamaterials sample. (b) Microscopic images of the THz metamaterial sample. (d,e) Comparisons of THz relative transmissions for different samples under the same pump power. (f) Modulation depths in transmission at 0.9 THz of different samples versus pumping laser power.

power of 4.56 W (here T_0 and T_p is THz transmission under pump power 0 W and P , respectively). Under a low pump power of 0.80 W, ΔT_M is about 33% at 0.9 THz. This is much larger than that of the unprocessed MOS sample, whose transmission decrease is only 16.6% under the same pump power. The modulation efficiency of the MOS sample almost doubled after the annealing treatment.

Devices based on graphene-metamaterial have been comprehensively applied in THz modulators. In our experiment, a sample of THz metamaterial made of gold was fabricated, as shown in Fig. 4b. Then a layer of graphene was transferred onto this sample and covered the metamaterial. Optically modulated THz transmission spectra of this graphene-metamaterial (Gr-Meta) sample were measured as a comparison for the GOS and the MOS samples. As shown in Fig. 4c, the Gr-Meta sample demonstrates a transmission dip at ~ 1 THz. Under a pump power of 4.56 W, the spectra demonstrate a transmission decrease from 39% to 5.8% at 0.9 THz. In Fig. 4d, transmission spectra under a pump power of 0.80 W of high-resistivity silicon, GOS, annealed MOS and Gr-Meta samples were compared. All the spectral results are divided by their corresponding transmission spectra without optical pumping, i.e., $T_{p=0.8W}/T_{p=0W}$. It is clearly demonstrated that the modulation efficiency of the annealed MOS sample is much higher than that of a silicon substrate, and even higher than that of the GOS sample. This is in sharp contrast with the results shown in Fig. 2d, as the MOS sample before annealing shows much worse modulation effect than the GOS sample. The Gr-Meta sample demonstrates higher modulation efficiency than the GOS sample, and is about the same level of the MOS sample. At lower frequencies, the Gr-Meta sample has higher modulation efficiency but at higher frequencies, the MOS sample works better. The transmission spectra of different samples under a larger pump power of 1.5 W are also compared in Fig. 4e. It can be found that the MOS sample shows higher modulation efficiency than the Gr-Meta sample, especially at higher frequencies and under a higher pump power.

To give a better view of the results, modulation depths of THz transmission at 0.9 THz of different samples are compared in Fig. 4f. The modulation depth is calculated as $M = (T_0 - T_p)/T_0$, where T_0 is the transmission without optical pumping and T_p is the transmission with pump power P . Under a relatively small pump power of 0.57 W, modulation depths are 14.7%, 22.6%, 27.3% and 31% for pure silicon, GOS, MOS and Gr-Meta, respectively. The modulation depth of MOS is nearly twice that of silicon. It can be seen that when the laser power is lower than 1 W, the modulation depth of MOS is smaller than that of Gr-Meta; nevertheless, when the laser power is higher than 1 W, the result is opposite. Under a pump power of 1.5 W, modulation depths for pure silicon, GOS, MOS and Gr-Meta are 25.4%, 44.5%, 57.5%, 52.7% respectively. Compared with pure silicon, modulation efficiencies of GOS, MOS and Gr-Meta have enhanced 75%, 126.4% and 107.5%, respectively. The modulation depths of these samples do not increase linearly with the laser power. At a large power of 4.56 W, the modulation depths are 93.1% for MOS, 85.4% for GOS and 84.8% for Gr-Meta.

As the annealing treatment significantly improves the property of MOS, it is expected that the modulation efficiency of MOS will be higher with longer annealing time. Therefore we treated the same sample of MOS with different annealing time and measured corresponding THz spectra modulated by the 808 nm CW laser. Results are shown in Fig. 5. The legends MOS-1, MOS-2, MOS-3 and MOS-4 represent MOS annealed in air at

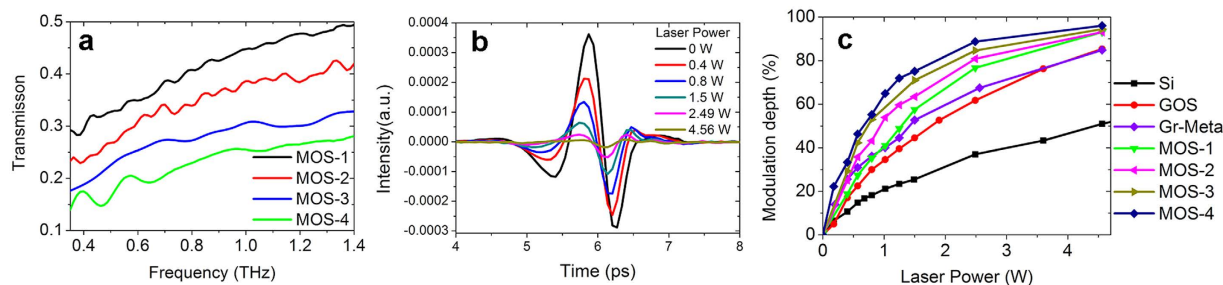


Figure 5. (a) THz spectra of the MOS sample with different annealing time, measured under an optical pump power of 1.5 W. (b) The time domain intensity of the transmission THz signal of the MOS-4 sample under different optical pump powers. (c) The relationship between modulation depths at 0.9 THz and the laser power for different samples.

300 °C for 0.5 h, 1.2 h, 3 h and 5 h respectively. As can be seen in Fig. 5a, transmission of MOS-4 is much smaller than that of MOS-1, which indicates that MOS-4 has a higher THz modulation efficiency. Under a large optical pump power, the transmission THz signal of MOS-4 almost vanishes (Fig. 5b). It is clearly demonstrated that the modulation depth of MOS increases with the annealing time in Fig. 5c. Under a pump power of 1 W, modulation depths at 0.9 THz for MOS-1, MOS-2, MOS-3 and MOS-4 are about 41.0%, 53.9%, 59.2% and 64.9%, respectively. An increase of 23.9% in modulation depth is achieved by treating the MOS sample with longer annealing time. Under the pump power of 1 W, modulation depths are 21.2% for silicon, 34.6% for GOS and 40.1% for Gr-Meta samples. So the modulation efficiency of MOS-4 is 3.07 times as high as that of pure silicon and 88% larger than that of GOS. It is also much larger than that of Gr-Meta (62% larger). When the pump power is as large as 4.56 W, modulation depths of MOS with different annealing time are close to 100% and approach to each other. For GOS and Gr-Meta samples, their modulation depths also reach the same point under a pump power of 4.56 W.

At lower frequencies, the THz modulation depth of MOS is also much larger than other samples. The relationship between modulation depths at 0.5 THz and the laser power is shown in Supplementary Information Fig. S1. Beside these samples above, we tried to combine annealed MoS₂ with metamaterials to give a larger modulation depth. However, the sample with annealed MoS₂ on metamaterials does not show any enhancement in THz modulation efficiency (see Supplementary Information Fig. S2). Additionally, the high-resistivity silicon sample with few-layer graphene covering on it (FLGOS) was also prepared and measured. FLGOS demonstrates lower THz modulation efficiency compared with GOS (see Supplementary Information Fig. S2).

Discussion

When the electric conductivity of a material increases, this material will absorb and reflect more THz waves, and its THz transmission will decrease. The conductivity of a material can be either tuned by an external voltage signal or exerting an optical pump signal to excite photo-generated carriers in silicon. In previous studies, the mechanism of a THz wave modulator based on optically tuned graphene-silicon structure was discussed in detail²². The modulation depth was enhanced by graphene compared with a pure silicon substrate. This effect has been attributed to considerable carriers diffusing from silicon into the graphene layer. Due to the higher mobility of graphene compared with silicon, these carriers in graphene layer result in a larger change of conductivity than that in pure silicon. This enhancement is verified in our experiments, as the GOS sample shows a larger modulation depth in transmission than the bare silicon substrate (Fig. 4d). However, for the MOS sample, the situation is different and this theory cannot explain the modulation enhancement, as the mobility of MoS₂ is as low as several cm²/V·s³⁸, much smaller than that of silicon. As a result, in contrary to what happens in the GOS sample, when charge carriers diffuse from silicon into the MoS₂ layer, they experience a mobility decline and may result in a drop of modulation depth. This is coincident with the experiment result shown in Fig. 2b.

It has been shown above that MoS₂ is p-doped after annealed in air. In this process the impurity concentration increases so the mobility of MoS₂ is expected to decrease³⁸. Meanwhile, the hole concentration of MoS₂ becomes larger and this makes the Fermi level energy moving to the valence band maximum. The change in energy band structure affects the way MoS₂ contacts with the silicon substrate. In the MOS sample without annealing treatment, both silicon and MoS₂ are n-doped, so the barrier at the silicon-MoS₂ interface is rather small and the corresponding built-in electric field is small. In contrast, in the annealed MOS sample, silicon and MoS₂ compose an n-p type heterostructure and the barrier at the silicon-MoS₂ is relatively large. Silicon and MoS₂ have electron affinities and energy band gaps with only small differences. The conduction band difference is 0.05 eV and the valence band difference is 0.03 eV. The band structure schemes of silicon-MoS₂ system are depicted in Fig. 6. The resistivity of the slightly n-doped silicon substrate is more than 5000 Ω·cm, therefore it can be interfered that the electric concentration in silicon is less than 10¹³ cm⁻³. The Fermi level energy E_F is about 0.06 eV upon the center of bandgap in silicon. In p-doped MoS₂, E_F is close to the valence band maximum. Hence the Fermi level energy in silicon is higher than that in MoS₂. When these two material contacts, electrons flow from silicon to MoS₂ and holes flow in the opposite direction. At equilibrium, the Fermi level energy is united and the built-in electric field is orientated from silicon to MoS₂. Due to the mismatch between the crystal lattices of silicon and MoS₂, there exist surface states at the interface of MoS₂, then E_F is pinned about 1/3 E_g (0.4 eV) upon the valence band maximum, as shown in Fig. 6b.

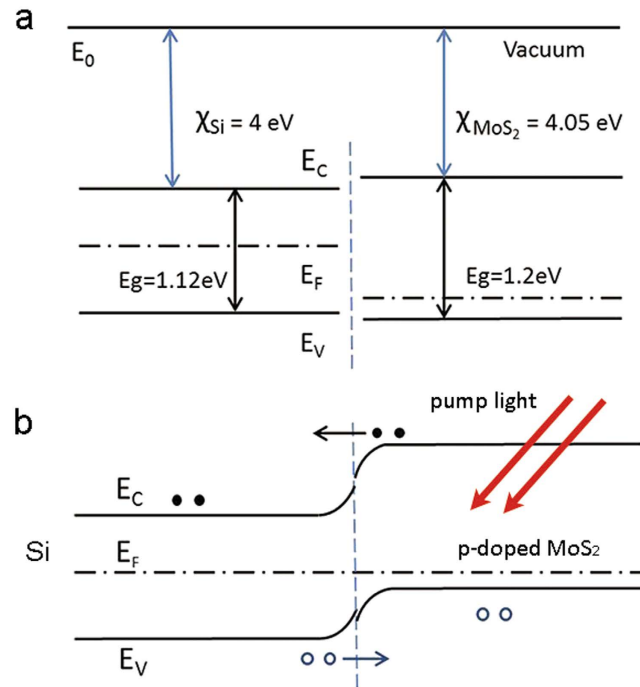


Figure 6. The band schemes of MoS₂-silicon system. (a) Energy bands of MoS₂ and silicon before they contact. (b) Band bending after MoS₂ and silicon contact and the flowing of photogenerated carriers.

When a pumping beam illuminates the MOS sample, nonequilibrium photogenerated carriers are excited both in silicon and in MoS₂. As MoS₂ layer is rather thin, it only absorbs a small part of pumping light. Most light are absorbed by silicon and most free charge carriers are generated in it. Moreover, nonequilibrium carriers in MoS₂ bear a rather low mobility, and only make a relatively small contribution to the change of the conductivity. Thus the conductivity change of the silicon-MoS₂ system is mainly determined by the generated free carriers in silicon, who gives an extra photoconductance to silicon. The photoconductance of silicon can be expressed as:

$$\Delta\sigma = e(\mu_n \Delta n + \mu_p \Delta p) \quad (1)$$

Here e is the elementary charge, μ_n and μ_p are charge mobilities of electrons and holes in silicon, respectively. Δn and Δp are concentrations of nonequilibrium electrons and holes generated by pump light. In slightly doped silicon, such as high-resistivity silicon used in our experiment, $\mu_n = 1450 \text{ cm}^2/\text{V}\cdot\text{s}$ and $\mu_p = 500 \text{ cm}^2/\text{V}\cdot\text{s}$.

Due to the built-in electric field, electrons diffuse from MoS₂ to silicon, and holes in silicon move to MoS₂. This makes Δn larger and Δp smaller in silicon compared with the case of pure silicon. As the electron mobility μ_n is nearly three times that of hole mobility μ_p , free electrons play a more important role in change of the photoconductance $\Delta\sigma$ than holes. Therefore, the increase in Δn gives rise to a larger $\Delta\sigma$, which results in lower THz transmission and a larger THz modulation depth. In addition, the p-doped MoS₂ has an effect similar with a minority carrier trap for silicon. In the slightly n-doped silicon, the number of photogenerated carriers is much larger than the intrinsic carriers. So the recombination probability and the lifetime τ of nonequilibrium electrons is mainly determined by Δp and τ is inversely proportional to Δp . The electronic-hole pairs are separated by the built-in electric field and a larger number of holes are trapped in MoS₂. The decrease of hole concentration Δp depresses the recombination probability of free electrons and holes in silicon and consequently increases the lifetime of free electrons. This leads to a larger Δn and an increase of the photoconductance of silicon. Hence an enhancement of THz modulation is observed in the annealed MOS sample. Our theory agrees well with results in Fig. 5. As the annealing time of MOS is increased, the Fermi level energy in MoS₂ is closer to the valence band and the built-in electric field becomes stronger. Therefore, under optical pumping, more electrons flow to silicon and more holes move from silicon to MoS₂. This leads to a larger enhancement of THz modulation efficiency for MOS.

We define the number of photogenerated electron-hole pairs per second and per cm² as N_g , then

$$N_g = \frac{P \cdot (1 - R)}{S \cdot h\nu} \cdot \beta \quad (2)$$

Herein, P is the laser power, R is reflection of pump light reflected from the sample, S is size of the illuminated area, $h\nu$ is the photon energy of pump light and β is the percentage of photons that effectively generate electron-hole pairs in silicon. When $P = 1 \text{ W}$, N_g can be estimated to be about $5 \times 10^{17} \text{ s}^{-1}\cdot\text{cm}^{-2}$.

Therefore the average concentration of generated carriers in the conducting silicon layer can be approximately described as $n_g = p_g = N_g \tau_g / d$, where τ_g is the lifetime of nonequilibrium carriers (the value of τ_g is assumed to be about $10 \mu\text{s}$) and d is the thickness of photogenerated conducting layer of silicon. According to equation (1),

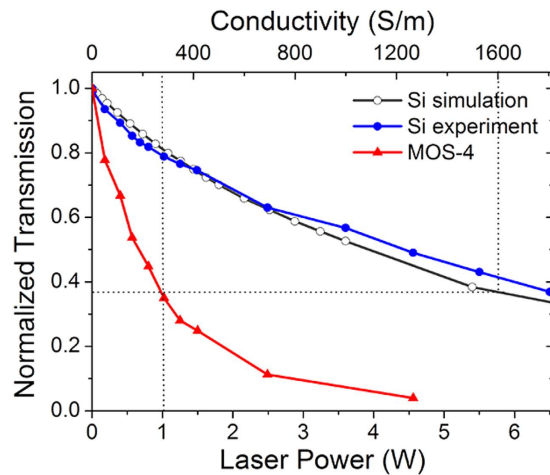


Figure 7. Simulated and measured transmissions (at 0.9 THz) of silicon substrate under different optical pump power, with experiment results of MOS-4 as a comparison. The top axis is the conductivity of the photogenerated conducting layer in silicon corresponding to the laser power.

the conductivity of silicon under pump power $P = 1$ W is $\sigma_g = n_g(\mu_n + \mu_p)e = 3 \Omega^{-1} \cdot \text{cm}^{-1}$, which is about 10^4 times larger than conductivity of the high-resistivity silicon without photodoping.

As the conductivity of silicon is proportional to the pump power, we can equivalently replace the pump light with the change in conductivity of silicon and carry out a simulation. In the simulation, THz waves ranging from 0.2–2.2 THz transmit a silicon wafer. The thickness of the photogenerated conducting layer of silicon is set to be $5 \mu\text{m}^2$. The calculated relationship between THz transmission and conductivity of silicon is shown in Fig. 7.

For MOS, due to the effect of MoS_2 layer, the electron concentration n_g increases while the hole concentration p_g decreases in silicon. Compared with pure silicon, the photoconductivity of MOS is $\sigma'_g = \sigma_g + \Delta\sigma_g = \sigma_g + \Delta\sigma_1 + \Delta\sigma_2$. Here $\Delta\sigma_g$ is the conductivity change caused by annealed MoS_2 , $\Delta\sigma_1$ is the change caused by injection of electrons from MoS_2 and decrease of p_g , and $\Delta\sigma_2$ is resulted by increase of n_g due to a longer lifetime of free electrons. However, as the number of electrons injected from MoS_2 is much less than n_g and the mobility of holes in silicon is small, $\Delta\sigma_1$ is relatively small compared with $\Delta\sigma_2$. Thus the conductivity change of the device is mainly dominated by $\Delta\sigma_2$. As mentioned above, $n_g = N_g \tau_g / d$, and τ_g is proportional to $1/p_g$. When holes in silicon flow to MoS_2 , if p_g decreases by about 80%, n_g will increase over 4 times and $\sigma'_g \approx 5\sigma_g = 15 \Omega^{-1} \text{cm}^{-1}$. Under a pump power $P = 1$ W, MOS-4 presents a THz transmission efficiency of 0.37 at 0.9 THz. This corresponds to a conductivity of about $16 \Omega^{-1} \text{cm}^{-1}$ according to our simulation model for silicon, about 5 times of σ_g , indicating that MoS_2 traps about 80% of generated holes in silicon.

In conclusion, we experimentally demonstrated an effective and broadband THz wave modulator based on optically tuned multilayer MoS_2 on silicon. With an annealing treatment in air, the MoS_2 was p-doped and showed dramatic changes in electrical and optical properties. The THz modulation depth at 0.9 THz increased from 16.6% to 33% after a preliminary annealing process with an optical pump power of 0.80 W. Further experiment results show that the THz modulation efficiency of MOS becomes much larger with longer annealing time. It exhibited a modulation depth of 64.9% at 0.9 THz under a pump power of 1 W, which is more than three times as larger as that of pure silicon. Under a larger pump power of 4.56 W, this depth is about 96%. Optically tuned THz modulators based on graphene-silicon and graphene-metamaterials were also fabricated and measured as comparisons. Results show that MOS annealed for 5 hours has a modulation efficiency 88% larger than that of GOS and 62% larger than Gr-Meta. Then we proposed an analytical model to explain this enhancement of THz modulation efficiency in annealed MOS. In our theory, MoS_2 traps much of photogenerated holes from the silicon substrate, which leads to a decrease in lifetime of free electrons and gives rise to an increase of electron concentration and conductivity of silicon. The numerically calculated THz transmission spectra agree well with experimental results. These results demonstrate that MoS_2 is a promising material to be applied in THz modulators with high efficiency.

Methods

Sample preparation. The $1 \text{ cm} \times 1 \text{ cm}$ multilayer MoS_2 film is grown on a SiO_2/Si sample. A layer of poly-methyl methacrylate (PMMA) was coated onto the sample. Then the SiO_2 layer was etched by the NaOH solution ($\sim 2 \text{ mol/L}$) and transferred to the high-resistivity silicon substrate whose size is $1.5 \text{ cm} \times 1.5 \text{ cm}$. During the annealing treatment of MoS_2 , the heating rate is $\sim 5^\circ\text{C}/\text{min}$. The ambient temperature stayed at 300°C for a time, and then the sample was cooled with a rate of $\sim 1.25^\circ\text{C}/\text{min}$. Samples were measured with protection of N_2 gas.

Theoretical and numerical calculation. Parameter values used in equation (2) are $R = 0.36$, $S = 1.76 \text{ cm}^2$, $h\nu = 1.54 \text{ eV}$, $\beta = 0.3$. The thickness of photogenerated conducting layer in silicon is $d = 5 \mu\text{m}$. The value of carrier's lifetime $\tau_g \approx 10 \mu\text{s}$. The numerical simulation was performed with a finite different time domain software

(Lumerical FDTD Solutions). In the simulation, the conductivity of the conducting silicon layer varied from 0.02 S/m to 2000 S/m. The conductivity of silicon corresponding to a pump power of 1 W was set to be 300 S/m.

References

- Federici, J. F. *et al.* THz imaging and sensing for security applications—explosives, weapons and drugs. *Semiconductor Science and Technology* **20**, S266 (2005).
- Wu, X. *et al.* Self-referenced sensing based on terahertz metamaterial for aqueous solutions. *Applied Physics Letters* **102**, (2013).
- Federici, J. & Moeller, L. Review of terahertz and subterahertz wireless communications. *Journal of Applied Physics* **107**, 111101 (2010).
- Koenig, S. *et al.* Wireless sub-THz communication system with high data rate. *Nat Photon* **7**, 977–981 (2013).
- Yu, N. *et al.* Designer spoof surface plasmon structures collimate terahertz laser beams. *Nat Mater* **9**, 730–735 (2010).
- Luo, L. *et al.* Broadband terahertz generation from metamaterials. *Nat Commun* **5** (2014).
- Vitiello, M. S. *et al.* Room-Temperature Terahertz Detectors Based on Semiconductor Nanowire Field-Effect Transistors. *Nano Lett* **12**, 96–101 (2012).
- Vicarelli, L. *et al.* Graphene field-effect transistors as room-temperature terahertz detectors. *Nat Mater* **11**, 865–871 (2012).
- Prasankumar, R. *et al.* Carrier dynamics in self-assembled ErAs nanoislands embedded in GaAs measured by optical-pump terahertz-probe spectroscopy. *Applied Physics Letters* **86**, 201107 (2005).
- Nozokido, T., Minamide, H. & Mizuno, K. Modulation of submillimeter wave radiation by laser-produced free carriers in semiconductors. *Electronics and Communications in Japan (Part II: Electronics)* **80**, 1–9 (1997).
- Gu, J. *et al.* Active control of electromagnetically induced transparency analogue in terahertz metamaterials. *Nat Commun* **3**, 1151 (2012).
- Zhu, W. M. *et al.* Microelectromechanical Maltese-cross metamaterial with tunable terahertz anisotropy. *Nat Commun* **3**, 1274 (2012).
- Karl, N. *et al.* An electrically driven terahertz metamaterial diffractive modulator with more than 20 dB of dynamic range. *Applied Physics Letters* **104**, 091115 (2014).
- Chen, H.-T. *et al.* A metamaterial solid-state terahertz phase modulator. *Nat Photon* **3**, 148–151 (2009).
- Chen, H.-T. *et al.* Active terahertz metamaterial devices. *Nature* **444**, 597–600 (2006).
- Liu, M. *et al.* Terahertz-field-induced insulator-to-metal transition in vanadium dioxide metamaterial. *Nature* **487**, 345–348 (2012).
- Gu, J. *et al.* An active hybrid plasmonic metamaterial. *Optical Materials Express* **2**, 31–37 (2012).
- Wen, Q.-Y. *et al.* Graphene based all-optical spatial terahertz modulator. *Scientific Reports* **4** (2014).
- Ju, L. *et al.* Graphene plasmonics for tunable terahertz metamaterials. *Nat Nano* **6**, 630–634 (2011).
- Sensale-Rodriguez, B. *et al.* Broadband graphene terahertz modulators enabled by intraband transitions. *Nat Commun* **3**, 780 (2012).
- Lee, S. H. *et al.* Switching terahertz waves with gate-controlled active graphene metamaterials. *Nat Mater* **11**, 936–941 (2012).
- Weis, P. *et al.* Spectrally wide-band terahertz wave modulator based on optically tuned graphene. *ACS nano* **6**, 9118–9124 (2012).
- Li, Q. *et al.* Active graphene-silicon hybrid diode for terahertz waves. *Nat Commun* **6** (2015).
- Li, Q. *et al.* Dual control of active graphene-silicon hybrid metamaterial devices. *Carbon* **90**, 146–153 (2015).
- Chen, H.-T. *et al.* Ultrafast optical switching of terahertz metamaterials fabricated on ErAs/GaAs nanoisland superlattices. *Optics Letters* **32**, 1620–1622 (2007).
- Chen, H.-T. *et al.* Hybrid metamaterials enable fast electrical modulation of freely propagating terahertz waves. *Applied Physics Letters* **93**, 091117 (2008).
- Chowdhury, D. R. *et al.* Dynamically reconfigurable terahertz metamaterial through photo-doped semiconductor. *Applied Physics Letters* **99**, 231101 (2011).
- Li, H. *et al.* From Bulk to Monolayer MoS₂: Evolution of Raman Scattering. *Advanced Functional Materials* **22**, 1385–1390 (2012).
- Zeng, H., Dai, J., Yao, W., Xiao, D. & Cui, X. Valley polarization in MoS₂ monolayers by optical pumping. *Nat Nano* **7**, 490–493 (2012).
- Mak, K. F., Lee, C., Hone, J., Shan, J. & Heinz, T. F. Atomically thin MoS₂: a new direct-gap semiconductor. *Physical Review Letters* **105**, 136805 (2010).
- Zhang, W. *et al.* High-Gain Phototransistors Based on a CVD MoS₂ Monolayer. *Advanced Materials* **25**, 3456–3461 (2013).
- Lopez-Sanchez, O., Lembke, D., Kayci, M., Radenovic, A. & Kis, A. Ultrasensitive photodetectors based on monolayer MoS₂. *Nat Nano* **8**, 497–501 (2013).
- Radisavljevic, B., Radenovic, A., Brivio, J., Giacometti, V. & Kis, A. Single-layer MoS₂ transistors. *Nat Nano* **6**, 147–150 (2011).
- McDonnell, S., Addou, R., Buie, C., Wallace, R. M. & Hinkle, C. L. Defect-dominated doping and contact resistance in MoS₂. *ACS nano* **8**, 2880–2888 (2014).
- Tongay, S. *et al.* Defects activated photoluminescence in two-dimensional semiconductors: interplay between bound, charged, and free excitons. *Scientific Reports* **3** (2013).
- Nan, H. *et al.* Strong photoluminescence enhancement of MoS₂ through defect engineering and oxygen bonding. *ACS nano* **8**, 5738–5745 (2014).
- Zhou, H. *et al.* Thickness-dependent patterning of MoS₂ sheets with well-oriented triangular pits by heating in air. *Nano Research* **6**, 703–711 (2013).
- Islam, M. R. *et al.* Tuning the electrical property via defect engineering of single layer MoS₂ by oxygen plasma. *Nanoscale* **6**, 10033–10039 (2014).
- Kang, N., Paudel, H. P., Leuenberger, M. N., Tetard, L. & Khondaker, S. I. Photoluminescence Quenching in Single-Layer MoS₂ via Oxygen Plasma Treatment. *The Journal of Physical Chemistry C* **118**, 21258–21263 (2014).
- Docherty, C. J. *et al.* Ultrafast Transient Terahertz Conductivity of Monolayer MoS₂ and WSe₂ Grown by Chemical Vapor Deposition. *ACS nano* **8**, 11147–11153 (2014).

Acknowledgements

The project was supported by the Science and Technology Plan of Beijing (No. Z141100004214001), the National Natural Science Foundation of China (No. 11104360) and the National Special Fund for the Development of Major Research Equipment and Instruments (No. 2012YQ14000508).

Author Contributions

Y.C. and Z.G. proposed the MoS₂-based modulator and designed the experiments. Y.C. fabricated the samples and measured THz spectra of the samples. S.G. and Q.B. provided the CVD MoS₂ sample and Raman spectra. P.Y. offered help in the measurement. Y.C. performed theoretical analysis and numerical calculating. Y.C., J.L., Z.G. and H.C. contributed to the writing of the manuscript. All the authors discussed the results.

Additional Information

Supplementary information accompanies this paper at <http://www.nature.com/srep>

Competing financial interests: The authors declare no competing financial interests.

How to cite this article: Cao, Y. *et al.* Optically tuned terahertz modulator based on annealed multilayer MoS₂. *Sci. Rep.* **6**, 22899; doi: 10.1038/srep22899 (2016).



This work is licensed under a Creative Commons Attribution 4.0 International License. The images or other third party material in this article are included in the article's Creative Commons license, unless indicated otherwise in the credit line; if the material is not included under the Creative Commons license, users will need to obtain permission from the license holder to reproduce the material. To view a copy of this license, visit <http://creativecommons.org/licenses/by/4.0/>